

## Electronic Acknowledgement Receipt

EFS ID:	1187115
Application Number:	10674631
Confirmation Number:	4703
Title of Invention:	Method and apparatus for endpoint detection during an etch process
First Named Inventor:	Shashank C. Deshmukh
Customer Number:	55649
Filer:	Alan Michael Taboada
Filer Authorized By:	
Attorney Docket Number:	8233/ETCH/SILICON/JB
Receipt Date:	06-SEP-2006
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Application Type:	Utility
International Application Number:	

### Payment information:

Submitted with Payment	no
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### File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1		8233-RFOA-9-6-06.pdf	115190	yes	13

	Multipart Description		
	Doc Desc	Start	End
	Amendment After Final	1	1
	Claims	2	6
	Applicant Arguments/Remarks Made in an Amendment	7	13

**Warnings:**

**Information:**

Total Files Size (in bytes):	115190
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**New Applications Under 35 U.S.C. 111**

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

**National Stage of an International Application under 35 U.S.C. 371**

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.